



COPY OF PATENT  
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FAU 2813  
PATENT

Case Docket No. ASMMC.036AUS

Date: August 20, 2002

Page 1

In re application of : SOPHIE et al.  
App. No. : 09/975,466  
Filed : October 9, 2001  
For : IN SITU REDUCTION OF  
COPPER OXIDE PRIOR TO  
SILICON CARBIDE  
DEPOSITION  
Examiner : Kielin, E.  
Art Unit : 2813

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